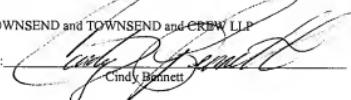


I hereby certify that this correspondence is being filed via
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MAIL STOP: AF on August 12, 2008

TOWNSEND and TOWNSEND and CROW LLP

By:



Cindy Bennett

**AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE –
EXAMINING GROUP 1792**

PATENT

Attorney Docket No.: 16301M-021300US

Client Ref. No.: AM2119/T21300

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Karl Littau et al.

Application No.: 08/893,917

Filed: July 11, 1997

For: REMOTE PLASMA CLEANING SOURCE
HAVING REDUCED REACTIVITY WITH
A SUBSTRATE PROCESSING CHAMBER

Customer No.: 57385

Confirmation No. 8435

Examiner: Rudy Zervigon

Technology Center/Art Unit: 1792

**AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1792**

MAIL STOP: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed June 12, 2008 (the "Office Action")
on the above-referenced application, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this
paper.

Remarks begin on page 4 of this paper.